



**ELECTRONIC COPY**

LG767606918  
Report verification at igi.org



January 24, 2026  
IGI Report Number **LG767606918**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **PRINCESS CUT**  
Measurements **9.29 X 9.23 X 6.63 MM**  
**GRADING RESULTS**  
Carat Weight **5.09 CARATS**  
Color Grade **E**  
Clarity Grade **VVS 2**

**LABORATORY GROWN DIAMOND REPORT**

January 24, 2026  
IGI Report Number **LG767606918**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **PRINCESS CUT**  
Measurements **9.29 X 9.23 X 6.63 MM**

**GRADING RESULTS**

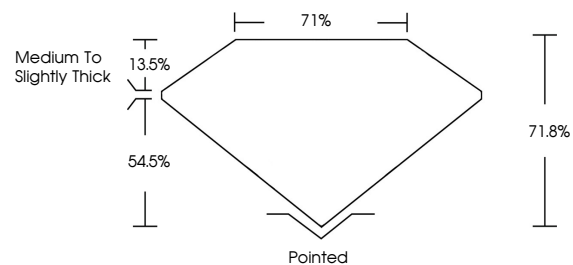
Carat Weight **5.09 CARATS**  
Color Grade **E**  
Clarity Grade **VVS 2**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG767606918**

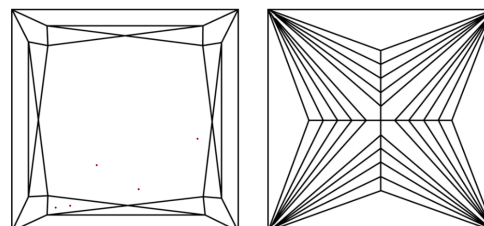
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

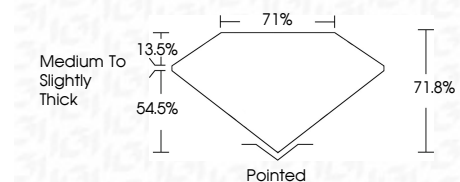
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG767606918**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa



January 24, 2026  
IGI Report No **LG767606918**  
**PRINCESS CUT**  
**5.09 CARATS**  
Color Grade **E**  
Clarity Grade **VVS 2**  
Table **71.0%**  
Depth **71.8%**  
Girdle **Medium to Slightly Thick**  
Culet **Pointed**  
Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG767606918**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa